

Abstract

There is disclosed a fabricating method of a plasma display panel which might simplify its fabricating process. A fabricating method of a plasma display panel according to an embodiment of the present invention includes the steps of: providing a sheet into which a black material layer and an electrode material layer are integrated; forming the sheet on a substrate; aligning a first mask on the front surface of a substrate where the sheet has been formed and exposing the sheet; aligning a second mask on the rear surface of the substrate and exposing the sheet; and developing the exposed sheet to form a bus electrode and a light shielding layer.